

Electronic Patent Application Fee Transmittal

Application Number:	09827307			
Filing Date:	06-Apr-2001			
Title of Invention:	Plasma processing apparatus and plasma processing method			
First Named Inventor/Applicant Name:	Tadahiro Ohmi			
Filer:	E. Rico Hernandez/Febes Lazo			
Attorney Docket Number:	P 280043 EL00026CDC			
Filed as Large Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				
Extension - 2 months with \$0 paid	1252	1	460	460

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	1801	1	810	810
Total in USD (\$)				1270